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## BIB DATA SHEET

CONFIRMATION NO. 4111

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/577,069	06/20/2006 RULE	257	2891	7372/88130

**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP04/16186 10/25/2004

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2003-365736 10/27/2003

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***  
12/29/2006

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Initials	JAPAN	6	9	2

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**TITLE**

Method for manufacturing compound semiconductor substrate

<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)

- 1.17 Fees (Processing Ext. of time)
- 1.18 Fees (Issue)
- Other \_\_\_\_\_
- Credit